



00862.022171

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takayuki YAGI et al.

Application No.: 09/819,672

Filed: March 29, 2001

For: ELECTRON OPTICAL SYSTEM ARRAY,
CHARGED-PARTICLE BEAM EXPOSURE
APPARATUS USING THE SAME, AND
DEVICE MANUFACTURING METHOD

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Examiner: K. Nguyen

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Group Art Unit: 2881

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Confirmation No.: 3159

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December 12, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

FIFTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statements filed on October 23, 2001, January 29, 2003, June 5, 2003, August 7, 2003, and November 6, 2003, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.


U.S. Patent Nos. 4,569,033 and 5,260,579 were cited in an attachment to a Notice of Allowance issued November 10, 2003, in copending U.S. patent application number 09/819,737.

Applicants request that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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